

## CAMD Metrology Request Form (Scanning Electron Microscopy, Optical Profilometry,)

Personal Contact Information:	Date:/
Name:Phone	e #: Department:
Project Reference #:	E-mail:
Substrate Description*	
1. Sample Name	
2. Substrate Material	
3. Material of Top Layer:	
4. Other substrate description details which may	y be necessary for analysis:
<ul> <li>5. The User may elect to be present during analy I request to be present for this analysis, p I do not need to be present</li> <li>6. Analysis description – include extra page (s) to I do not need to be present</li> </ul>	
7. If areas of investigation are non-metallic, specotherwise standard thickness for your application.	ecify the preferable thickness of gold coating depositedÅ ation will be applied
<ul> <li>* Please include a form for each sample unless it is a batch analysis</li> <li>Forward sample and form to Varshni Singh, LSU/CAMD room #130, visngh2@lsu.edu, 225-578-0248</li> <li>For technical issues contact Varshni Singh, vsingh2@lsu.edu, 225-578-0248</li> <li>If special considerations are necessary, please include detailed instructions</li> <li>If is your responsibility to ensure satisfactory sample conditions for analysis</li> <li>Please allow (5) working days for processing</li> </ul>	
CAMD Office Use:	
Date Received: Anticipated Completion Date:	Comments:
Performed by: Approved by: Date:	Signature of recipient:

Date received: